

<b>Notice of References Cited</b>		Application/Control No. 10/590,004	Applicant(s)/Patent Under Reexamination HIGUCHI ET AL.	
		Examiner Wayne K. Leung	Art Unit 4171	Page 1 of 1

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**NON-PATENT DOCUMENTS**

*	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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